NOV. 11. 2008 5:03PM . MOFO 28TH FL NO. 986 P. 1 MORTISON & FORRSTER LLT 425 MARKET STREET MORRISON | FOERSTER NEW YORK, SAN FRANCISCO. SAN FRANCISCO LOS ANGRLES, PALO ALTO, SAN DIBGO, WASHINGTON, D.C. CALIFORNIA 94105-2482 DENVER, NORTHERN VIRGINIA, OLANGE COUNTY, SACRAMENTO, TELEPHONE: 415.268.7000 FACSIMILE: 415.268.7522 WALRUT CREEK, CENTURY CITY TOKTO, LONDON, BEIJING, SHANGHAI, HONG KONG, BINGAPORE, BRUSSELS WWW.MOFO.COM RECEIVED **CENTRAL FAX CENTER** NOV 1 2 2008 To: NAME: Telephone: FACSIMILE: U.S. Patent and Trademark Office (571) 272-4105 (571) 273-8300 ATTN: CENTRALIZED FAX CENTER November 11, 2008 DATE: Peter Yim FROM: Reg. No. 44,417 Number of pages 2 with cover page: Preparer of this slip has confirmed that facsimple number given is <u>РЈҮ1/8566</u> correct: CAUTION - CONFIDENTIAL This facsimile contains confidential information which may also be privileged. Unless you are the addressee (or authorized to receive for the addressee), you may not copy, use, or distribute it. If you have received it in error, please advise Morrison & Foerster LLP immediately by telephone or facsimile and return it promptly by mail. Comments: PLEASE PROCESS THE ATTACHED. U.S. Patent Application No. 10/608 \$\ 00 For: OPTICAL METROLOGY OF STRUCTURES FORMED ON SEMICONDUCTOR WAFER USING MACHINE LEARNING SYSTEM By: Srinivas DODDI et al. Our reference: 50998-20055.00 Attached is the following: Notice of Hearing Confirmation (1 page) sf-2141898 PAGE 1/2 * RCVD AT 11/11/2008 8:03:03 PM [Eastern Standard Time] * SVR:USPTO-EFXRF-6/43 * DNIS:2738300 * CSID:415 2687522 * DURATION (mm-ss):00-36

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